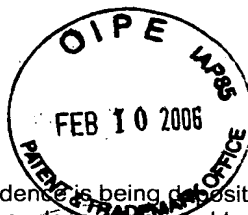


Docket No.: RSW-S3019



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I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date indicated below.

By: 

Date: February 7, 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No.	:	10/806,512	Confirmation No.:	3891
Applicant	:	Maik Stegemann, et al.		
Filed	:	March 22, 2004		
Title	:	Method for Fabricating a Semiconductor Structure		
Art Unit	:	2811		
Examiner	:	to be assigned		
Docket No.	:	RSW-S3019		
Customer No.	:	24131		

INFORMATION DISCLOSURE STATEMENT

Hon. Commissioner for Patents  
Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. 1.98 copies of the following patents and/or publications are cited herewith:

United States Patent No. 5,022,959 (Itoh, et al.), dated June 11, 1991;

United States Patent Application Publication US 2003/0003725 A1 (Uesawa), dated January 2, 2003;

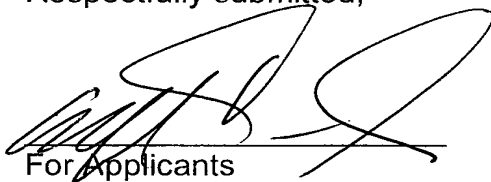
European Patent Application EP 0 416 809 A2 (Hills), dated March 13, 1991;

German Examination Report dated November 11, 2005.

In accordance with 37 C.F.R. 1.97(e) the undersigned herewith states that each item of information contained in the information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement.

As per the Notice in 1273 OG 55 (August 5, 2003) no copies of any above-mentioned U.S. patents and U.S. patent application publications are submitted for any application filed after June 30, 2003.

Respectfully submitted,



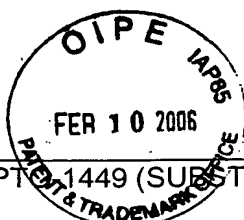
For Applicants

**Alfred K. Dassler**  
**52,794**

Date: February 7, 2006

Lerner Greenberg Sterner LLP  
Post Office Box 2480  
Hollywood, FL 33022-2480  
Tel: (954) 925-1100  
Fax: (954) 925-1101

/am



FORM PTOL 1449 (SUBSTITUTE)  U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  <p style="text-align: center;"><b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>          (37 CFR 1.98(b))</p>	<table style="width: 100%; border-collapse: collapse;"> <tr> <td style="width: 50%;">Attorney Docket No.: <b>RSW-S3019</b></td> <td style="width: 50%;">Applic. No. <b>10/806,512</b></td> </tr> <tr> <td colspan="2" style="border-top: 1px solid black; padding-top: 5px;">           Applicant  <p style="text-align: center;"><b>Maik Stegemann, et al.</b></p> </td> </tr> <tr> <td style="border-top: 1px solid black; padding-top: 5px;">Filing Date <b>March 22, 2004</b></td> <td style="border-top: 1px solid black; padding-top: 5px;">Group Art Unit <b>2811</b></td> </tr> </table>	Attorney Docket No.: <b>RSW-S3019</b>	Applic. No. <b>10/806,512</b>	Applicant <p style="text-align: center;"><b>Maik Stegemann, et al.</b></p>		Filing Date <b>March 22, 2004</b>	Group Art Unit <b>2811</b>
Attorney Docket No.: <b>RSW-S3019</b>	Applic. No. <b>10/806,512</b>						
Applicant <p style="text-align: center;"><b>Maik Stegemann, et al.</b></p>							
Filing Date <b>March 22, 2004</b>	Group Art Unit <b>2811</b>						

**U.S. PATENT DOCUMENTS**

EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	A	5,022,959	6/1991	Itoh, et al.			
	B	2003/0003725 A1	1/2003	Uesawa			
	C						
	D						
	E						
	F						
	G						
	H						
	I						

**FOREIGN PATENT DOCUMENT**

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES   NO
	J	0 416 809 A2	3/1991	Europe			
	K						
	L						
	M						
	N						

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)**

	O	
	P	

<b>EXAMINER</b>	<b>DATE CONSIDERED</b>
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**EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.